

# Dmitri Pavlov

## List of Publications by Year in descending order

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103  
papers

876  
citations

687220

13  
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526166

27  
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109  
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109  
docs citations

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times ranked

740  
citing authors

#	ARTICLE	IF	CITATIONS
1	Impact of metallic coating on the retention of $^{225}\text{Ac}$ and its daughters within core-shell nanocarriers. <i>Journal of Colloid and Interface Science</i> , 2022, 608, 2571-2583.	5.0	5
2	Influence of chemical nature of implanted atoms on photoluminescence of ion-synthesized 9R-Si hexagonal silicon. <i>Materials Letters</i> , 2022, 308, 131103.	1.3	2
3	Growth defects in GeSn/Ge/Si(001) epitaxial layers grown by hot wire chemical vapor deposition of Ge with co-evaporation of Sn. <i>Journal of Crystal Growth</i> , 2022, 578, 126421.	0.7	1
4	Resistive switching in metal-oxide memristive materials and devices. , 2022, , 33-78.		0
5	Technology and neuromorphic functionality of magnetron-sputtered memristive devices. , 2022, , 109-131.		0
6	Silicon-Compatible Memristive Devices Tailored by Laser and Thermal Treatments. <i>Journal of Low Power Electronics and Applications</i> , 2022, 12, 14.	1.3	3
7	Comparison of III-V Heterostructures Grown on Ge/Si, Ge/SOI, and GaAs. <i>Semiconductors</i> , 2022, 56, 122-133.	0.2	1
8	Ion-Beam Synthesis of Gallium Oxide Nanocrystals in a SiO <sub>2</sub> /Si Dielectric Matrix. <i>Nanomaterials</i> , 2022, 12, 1840.	1.9	3
9	Noise-assisted persistence and recovery of memory state in a memristive spiking neuromorphic network. <i>Chaos, Solitons and Fractals</i> , 2021, 146, 110890.	2.5	76
10	A mechanism of effect of optical excitation on resistive switching in ZrO <sub>2</sub> (Y) films with Au nanoparticles. <i>Journal Physics D: Applied Physics</i> , 2021, 54, 485303.	1.3	4
11	Memristive Spike- Timing-Dependent Plasticity. , 2021, , .		3
12	Electrical Properties of Silicon-Oxide-Based Memristors on Silicon-on-Insulator Substrates. <i>Nanobiotechnology Reports</i> , 2021, 16, 745-754.	0.2	0
13	Investigation of resistive switching in Ag/Ge/Si(001) stack by conductive atomic force microscopy. <i>Journal of Physics: Conference Series</i> , 2021, 2086, 012043.	0.3	0
14	Multilayer Metal-Oxide Memristive Device with Stabilized Resistive Switching. <i>Advanced Materials Technologies</i> , 2020, 5, 1900607.	3.0	78
15	Growth of a Ge Layer on a Si/SiO <sub>2</sub> /Si(100) Structure by the Hot Wire Chemical Vapor Deposition. <i>Semiconductors</i> , 2020, 54, 1332-1335.	0.2	1
16	Circularly Polarized Electroluminescence of Spin LEDs with a Ferromagnetic (In, Fe)Sb Injector. <i>Technical Physics Letters</i> , 2020, 46, 691-694.	0.2	1
17	Photoluminescence of silicon at 1235Ånm produced by irradiation of SiO <sub>2</sub> /Si with Kr <sup>+</sup> ions and subsequent high-temperature annealing. <i>Surface and Coatings Technology</i> , 2020, 386, 125496.	2.2	5
18	Electrophysical Characteristics of Multilayer Memristive Nanostructures Based on Yttria-Stabilized Zirconia and Tantalum Oxide. <i>Technical Physics</i> , 2020, 65, 284-290.	0.2	4

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19	Light-emitting hexagonal 9R-Si phase obtained by implantation of Kr <sup>+</sup> ions in Si and SiO <sub>2</sub> /Si. Journal of Physics: Conference Series, 2020, 1695, 012031.	0.3	1
20	Resistive Switching in Memristors Based on Ge/Si(001) Epitaxial Layers. Semiconductors, 2020, 54, 1833-1835.	0.2	2
21	Bipolar resistive switching in memristors based on Ge/Si(001) epitaxial layers. Journal of Physics: Conference Series, 2020, 1695, 012158.	0.3	2
22	High-temperature intrinsic ferromagnetism in heavily Fe-doped GaAs layers. Semiconductor Science and Technology, 2020, 35, 125032.	1.0	7
23	On the Combined Application of Raman Spectroscopy and Photoluminescence Spectroscopy for the Diagnostics of Multilayer Heterostructures. Semiconductors, 2019, 53, 1207-1210.	0.2	0
24	Studies of the Cross Section and Photoluminescence of a GaAs Layer Grown on a Si/Al <sub>2</sub> O <sub>3</sub> Substrate. Semiconductors, 2019, 53, 1242-1245.	0.2	1
25	Diode Structures Based on (In, Fe)Sb/GaAs Magnetic Heterojunctions. Technical Physics Letters, 2019, 45, 668-671.	0.2	1
26	Yttria-stabilized zirconia cross-point memristive devices for neuromorphic applications. Microelectronic Engineering, 2019, 215, 110988.	1.1	61
27	Formation of epitaxial p-i-n structures on the basis of (In,Fe)Sb and (Ga,Fe)Sb diluted magnetic semiconductor layers. Journal of Magnetism and Magnetic Materials, 2019, 487, 165321.	1.0	8
28	Robustness of ferromagnetism in (In,Fe)Sb diluted magnetic semiconductor to variation of charge carrier concentration. Journal of Magnetism and Magnetic Materials, 2019, 485, 236-243.	1.0	9
29	The nature of transport and ferromagnetic properties of the GaAs structures with the Mn $\delta$ -doped layer. Journal of Magnetism and Magnetic Materials, 2019, 478, 84-90.	1.0	7
30	Mechanism of formation of light-emitting silicon hexagonal phase 9R-Si. Journal of Physics: Conference Series, 2019, 1410, 012037.	0.3	1
31	Deep UV narrow-band photodetector based on ion beam synthesized indium oxide quantum dots in Al <sub>2</sub> O <sub>3</sub> matrix. Nanotechnology, 2018, 29, 305603.	1.3	18
32	Ripplocation in graphite nanoplatelets during sonication assisted liquid phase exfoliation. Carbon, 2018, 129, 826-829.	5.4	27
33	Enhanced Solar-Blind Photodetection Performance of Encapsulated Ga <sub>2</sub> O <sub>3</sub> Nanocrystals in Al <sub>2</sub> O <sub>3</sub> Matrix. IEEE Sensors Journal, 2018, 18, 4046-4052.	2.4	11
34	Formation of hexagonal silicon regions in silicon. Journal of Physics: Conference Series, 2018, 1124, 022007.	0.3	1
35	Investigation of local charge accumulation in yttria stabilized zirconia films with Au nanoparticles by Scanning Kelvin Probe Microscopy. Journal of Physics: Conference Series, 2018, 1124, 081028.	0.3	0
36	Relation between the Electronic Properties and Structure of InAs/GaAs Quantum Dots Grown by Vapor-Phase Epitaxy. Semiconductors, 2018, 52, 1525-1528.	0.2	0

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37	Light-emitting 9R-Si phase formed by Kr <sup>+</sup> ion implantation into SiO <sub>2</sub> /Si substrate. Applied Physics Letters, 2018, 113, .	1.5	14
38	Conductive Atomic Force Microscopy Study of the Resistive Switching in Yttria-Stabilized Zirconia Films with Au Nanoparticles. Scanning, 2018, 2018, 1-9.	0.7	4
39	X-Ray Photoelectron Spectroscopy of Stabilized Zirconia Films with Embedded Au Nanoparticles Formed under Irradiation with Gold Ions. Physics of the Solid State, 2018, 60, 598-602.	0.2	1
40	MOCVD Growth of InGaAs/GaAs/AlGaAs Laser Structures with Quantum Wells on Ge/Si Substrates. Crystals, 2018, 8, 311.	1.0	11
41	Effect of Boron Impurity on the Light-Emitting Properties of Dislocation Structures Formed in Silicon by Si <sup>+</sup> Ion Implantation. Semiconductors, 2018, 52, 843-848.	0.2	6
42	GaAs/Ge/Si epitaxial substrates: Development and characteristics. AIP Advances, 2017, 7, .	0.6	20
43	An oscillator based on a single Au nanocluster. Journal of Applied Physics, 2017, 121, 014308.	1.1	3
44	Influence of the deposition and annealing temperatures on the luminescence of germanium nanocrystals formed in GeO <sub>x</sub> films and multilayer Ge/SiO <sub>2</sub> structures. Physics of the Solid State, 2017, 59, 992-998.	0.2	0
45	Peculiarities of growing InGaAs/GaAs/AlGaAs laser structures by MOCVD on Ge/Si substrates. Semiconductors, 2017, 51, 1527-1530.	0.2	5
46	Features of the selective manganese doping of GaAs structures. Semiconductors, 2017, 51, 1415-1419.	0.2	1
47	Single-phase epitaxial InFeSb layers with a Curie temperature above room temperature. Physics of the Solid State, 2017, 59, 2220-2222.	0.2	4
48	High-temperature intrinsic ferromagnetism in the (In,Fe)Sb semiconductor. Journal of Applied Physics, 2017, 122, .	1.1	25
49	Effect of the cap-layer composition on the electronic properties of InAs/GaAs quantum dots. Semiconductors, 2017, 51, 1395-1398.	0.2	0
50	Formation of hexagonal 9R silicon polytype by ion implantation. Technical Physics Letters, 2017, 43, 767-769.	0.2	8
51	Electrically pumped InGaAs/GaAs quantum well microdisk lasers directly grown on Si(100) with Ge/GaAs buffer. Optics Express, 2017, 25, 16754.	1.7	13
52	Filamentary model of bipolar resistive switching in capacitor-like memristive nanostructures on the basis of yttria-stabilised zirconia. International Journal of Nanotechnology, 2017, 14, 604.	0.1	24
53	Resistive switching in the Au/Zr/ZrO <sub>2</sub> -Y <sub>2</sub> O <sub>3</sub> /TiN/Ti memristive devices deposited by magnetron sputtering. Journal of Physics: Conference Series, 2016, 741, 012174.	0.3	11
54	Monolithically integrated InGaAs/GaAs/AlGaAs quantum well laser grown by MOCVD on exact Ge/Si(001) substrate. Applied Physics Letters, 2016, 109, .	1.5	24

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55	Forming dense arrays of gold nanoparticles in thin films of yttria stabilized zirconia by magnetron sputtering. <i>Technical Physics Letters</i> , 2016, 42, 36-39.	0.2	13
56	Layer-by-layer composition and structure of silicon subjected to combined gallium and nitrogen ion implantation for the ion synthesis of gallium nitride. <i>Semiconductors</i> , 2016, 50, 271-275.	0.2	7
57	On the crystal structure and thermoelectric properties of thin Si <sub>1-x</sub> Mn <sub>x</sub> films. <i>Semiconductors</i> , 2016, 50, 1453-1457.	0.2	1
58	Field- and irradiation-induced phenomena in memristive nanomaterials. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2016, 13, 870-881.	0.8	92
59	Fabrication of MnGa/GaAs contacts for optoelectronics and spintronics applications. <i>Semiconductors</i> , 2016, 50, 1443-1448.	0.2	0
60	Distribution of D1 dislocation luminescence centers in Si <sup>+</sup> -implanted silicon and the photoluminescence model. <i>Modern Electronic Materials</i> , 2015, 1, 33-37.	0.2	3
61	Application of cobalt in spin light-emitting Schottky diodes with InGaAs/GaAs quantum wells. <i>Journal of Surface Investigation</i> , 2015, 9, 706-709.	0.1	9
62	Growth of light-emitting SiGe heterostructures on strained silicon-on-insulator substrates with a thin oxide layer. <i>Semiconductors</i> , 2015, 49, 1104-1110.	0.2	3
63	Ion-beam synthesis of GaN in silicon. <i>Journal of Physics: Conference Series</i> , 2015, 643, 012082.	0.3	2
64	Formation of Au <sub>4</sub> Zr nanocrystals in yttria stabilized zirconia in the course of implantation of gold ions. <i>Technical Physics Letters</i> , 2015, 41, 543-546.	0.2	4
65	Localization of dislocation-related luminescence centers in self-ion implanted silicon and effect of additional boron ion doping. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2015, 12, 84-88.	0.8	4
66	Influence of the technological parameters of growth on the characteristics of double tunnel-coupled InGaAs/GaAs quantum wells. <i>Semiconductors</i> , 2015, 49, 55-59.	0.2	1
67	Bipolar resistive switching and charge transport in silicon oxide memristor. <i>Materials Science and Engineering B: Solid-State Materials for Advanced Technology</i> , 2015, 194, 48-54.	1.7	75
68	Epitaxial growth of hexagonal silicon polytypes on sapphire. <i>Semiconductors</i> , 2015, 49, 95-98.	0.2	7
69	Effect of thermal annealing on the emission properties of heterostructures containing a quantum-confined GaAsSb layer. <i>Semiconductors</i> , 2015, 49, 9-12.	0.2	1
70	Study of the crystal structure of silicon nanoislands on sapphire. <i>Semiconductors</i> , 2015, 49, 154-156.	0.2	0
71	Structural, optical, and current investigations of superlattices with a complex AlGaAs-based unit cell. <i>Semiconductors</i> , 2015, 49, 118-123.	0.2	1
72	Distribution of elastic strains appearing in gallium arsenide as a result of doping with isovalent impurities of phosphorus and indium. <i>Semiconductors</i> , 2015, 49, 1-3.	0.2	2

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73	Impact of growth and annealing conditions on the parameters of Ge/Si(001) relaxed layers grown by molecular beam epitaxy. <i>Semiconductors</i> , 2015, 49, 1415-1420.	0.2	23
74	Self-assembled nanocrystals discovered in Chelyabinsk meteorite. <i>Scientific Reports</i> , 2015, 4, 4280.	1.6	5
75	Epitaxial growth of MnGa/GaAs layers for diodes with spin injection. <i>Physics of the Solid State</i> , 2014, 56, 2131-2134.	0.2	3
76	Investigation of deformations and strain fields in silicon matrix structures embedded with vertically stacked Ge(Si) self-assembled islands. <i>Applied Physics Letters</i> , 2014, 105, .	1.5	5
77	Annealing-induced evolution of the structural and morphological properties of a multilayer nanoporous SiO <sub>x</sub> /ZrO <sub>2</sub> system containing Si nanoclusters. <i>Semiconductors</i> , 2014, 48, 42-45.	0.2	8
78	Effect of ion doping on the dislocation-related photoluminescence in Si <sup>+</sup> -implanted silicon. <i>Semiconductors</i> , 2014, 48, 199-203.	0.2	7
79	Anomalous Hall effect in two-phase semiconductor structures: The role of ferromagnetic inclusions. <i>Physical Review B</i> , 2014, 90, .	1.1	12
80	Effect of ion irradiation on the structure and luminescence characteristics of porous silicon impregnated with tungsten-telluride glass doped by Er and Yb impurities. <i>Physics of the Solid State</i> , 2014, 56, 631-634.	0.2	1
81	Capacitors with nonlinear characteristics based on stabilized zirconia with built-in gold nanoparticles. <i>Technical Physics Letters</i> , 2014, 40, 369-371.	0.2	13
82	Structure and luminescence of silicon irradiated by protons. <i>Inorganic Materials: Applied Research</i> , 2014, 5, 133-137.	0.1	0
83	Quenching the photoluminescence from Si nanocrystals of smaller sizes in dense ensembles due to migration processes. <i>Journal of Luminescence</i> , 2014, 155, 1-6.	1.5	8
84	Thermal evolution of the morphology, structure, and optical properties of multilayer nanoporous systems produced by the vacuum evaporation of SiO and SiO <sub>2</sub> . <i>Semiconductors</i> , 2013, 47, 481-486.	0.2	15
85	Analysis of the growth dependences of silicon-on-sapphire heteroepitaxy. <i>Semiconductors</i> , 2013, 47, 865-869.	0.2	0
86	Growth model of silicon nanoislands on sapphire. <i>Semiconductors</i> , 2013, 47, 1595-1597.	0.2	2
87	A method for determining the state of the silicon-sapphire boundary in thin silicon-on-sapphire layers. <i>Russian Microelectronics</i> , 2013, 42, 529-531.	0.1	0
88	Influence of the ion synthesis and ion doping regimes on the effect of sensitization of erbium emission by silicon nanoclusters in silicon dioxide films. <i>Physics of the Solid State</i> , 2013, 55, 2361-2367.	0.2	0
89	Influence of ion irradiation on the morphology, structure, and optical properties of gold nanoparticles synthesized in SiO <sub>2</sub> and Al <sub>2</sub> O <sub>3</sub> dielectric matrices. <i>Journal of Surface Investigation</i> , 2012, 6, 681-687.	0.1	1
90	Investigation of silicon-on-sapphire structures by means of TEM. <i>Bulletin of the Russian Academy of Sciences: Physics</i> , 2012, 76, 1002-1004.	0.1	3

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91	Tunnel-coupled InGaAs/GaAs quantum wells: Structure, composition, and energy spectrum. Semiconductors, 2012, 46, 1476-1480.	0.2	5
92	Peculiarities in the formation of gold nanoparticles by ion implantation in stabilized zirconia. Technical Physics Letters, 2012, 38, 185-187.	0.2	9
93	Growing nanocrystalline silicon on sapphire by molecular beam epitaxy. Technical Physics Letters, 2010, 36, 548-550.	0.2	5
94	Sapphire surface preparation for the growth of silicon layers by molecular-beam epitaxy. Inorganic Materials, 2010, 46, 693-702.	0.2	0
95	<title>Molecular-beam epitaxy of ultrathin Si films on sapphire</title>. , 2008, , .		1
96	Structural perfection of heteroepitaxial silicon layers grown on sapphire by sublimation-source molecular beam epitaxy. Inorganic Materials, 2007, 43, 331-337.	0.2	1
97	Heteroepitaxy of Erbium-Doped Silicon Layers on Sapphire Substrates. Physics of the Solid State, 2005, 47, 89.	0.2	2
98	Structural and photoluminescence properties of heteroepitaxial silicon-on-sapphire layers. Physics of the Solid State, 2004, 46, 10-12.	0.2	2
99	Hydrogen sensitivity of a silicon Schottky diode increased by modification of the semiconductor surface microrelief. Technical Physics Letters, 2002, 28, 355-356.	0.2	0
100	Nonmonotonic character of the growth-temperature dependence of the resistance of polycrystalline silicon films. Semiconductors, 1998, 32, 562-564.	0.2	1
101	Structure and electrical conductivity of polycrystalline silicon films grown by molecularbeam deposition accompanied by low-energy ion bombardment of the growth surface. Semiconductors, 1997, 31, 237-240.	0.2	0
102	Structure and properties of amorphous silicon doped with isovalent impurities. Physica Status Solidi A, 1989, 116, 697-702.	1.7	0
103	The Properties of Amorphous Silicon Doped with Isovalent Impurities. Physica Status Solidi (B): Basic Research, 1987, 142, K125.	0.7	1